AUTOMATED MANUFACTURE OF SEMICONDUCTORS USING NANOMATERIALS

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INDUSTRY CURRENTLY CANNOT USE NANOMATERIALS

- Grown nanomaterials are randomly distributed on substrates
- Finding them is **manually-intensive** and **time-consuming**
- Currently **unscalable** for industrial manufacturing



OUR SOLUTION: AN AUTOMATED LOCATION SYSTEM FOR NANOMATERIALS



Nanowires on silicon with LithoTags^{TI}

AUTOMATED FABRICATION OF NANOWIRE TRANSISTORS

Using our method we **automatically manufactured** over 200 nanowire transistors (Potocnik et al. ACS Nano. 2022)



Nanowire transistors dispered on silicon with LithoTag[™] array



NANOMATERIAL-BASED CHIPS IN EVERYDAY ELECTRONICS

- 12,000x faster manufacture of nanomaterial-based chips
 Unlocks use of nanomaterials in commercial electronics
- Nanomaterial-based chips use less energy
- Reducing dependence on rare earths increases the resilience of the semiconductor supply chain



Automated manufacturing with LithoTags™